Interface engineering and efficiency improvement of monolayer

graphene-silicon solar cells by inserting an ultra-thin LiF interlayer

Dikai Xu, Xuegong Yu*, Lijian Zuo, Deren Yang

Supporting Information

1. Extraction the values of series resistances of solar cells

Relation between current density and voltage (*J-V*) under dark condition can be expressed by equation (S1.1) when series resistance (R_s) is taken into account, ¹⁻³

$$J = J_s(\exp(\frac{q(V - JR_s)}{nkT}) - 1)$$
(S1.1)

where J_s is the reversed saturation current density, *T* the absolute temperature (298 K) and *V*-*JR*_s the voltage applied across the Schottky solar cells. For $V - JR_s > 3kT/q$, the *J*-*V* relation becomes as follows,

$$J = J_s \exp\left[\frac{q(V - JR_s)}{nkT}\right]$$
(S1.2)

Equation (S1.2) can be differentiated and rearranged into formula as follows,

$$\frac{dV}{d(\ln J)} = R_s A_{eff} J + \frac{nkT}{q}$$
(S1.3)

where A_{eff} is effective area of Schottky solar cells. The value of R_{s} is obtained from slope of $dV/d(\ln J)$ versus J curves.

2. Calculation of the values of contact resistances

The values of contact resistance, $\rho_{\rm C}$, for the Al/Si direct contact and the Al/LiF/Si

contact, are extracted by the transmission line model method.⁴ Detailed extraction process is described as follows. Current-voltage (*I-V*) curves between two contacts with length *d* and width *W* were measured by a probing station. As shown in the inset of Figure 5, the distance between Al electrodes were 100, 200, 300, *etc.* then finally 600 μ m. The total resistances, *R*_T, between every two electrodes are derived from the *I-V* curves, correspondingly. The contact resistance, *R*_C, can be obtained by fitting equation (S2.1) as follows,

$$R_T = 2R_C + R_{sh}\mathbf{g}/W \tag{S2.1}$$

where the $R_{\rm sh}$ is the sheet resistance of Si and *l* the distances between two electrodes. The value of $L_{\rm T}$ is obtained by equation (S2.2) and (S2.3) as follows,

$$R_E = \frac{1}{2}(R_1 + R_2 - R_3)$$
(S2.2)

$$R_C/R_E = \cosh(d/L_T) \tag{S2.3}$$

where $R_{\rm E}$ is the contact end resistance, $L_{\rm T}$ the transfer length and *d* the length of electrodes. Schematic diagram of R_1 , R_2 and R_3 is shown in Figure S1. Eventually, $\rho_{\rm C}$ is extracted from equation (S2.4),

$$\rho_c = R_E L_T W \sinh(d/L_T) \tag{S2.4}$$

The calculated contact resistances for the Al/Si and Al/LiF/Si contact were 1.9×10^{-1} Ω cm² and $6.3 \times 10^{-2} \Omega$ cm², respectively.

Nominal thickness	$V_{\rm OC}({\rm mV})$	$J_{\rm SC}~({\rm mA/cm^2})$	FF (%)	PCE (%)
Of LiF interlayer				
1.2 nm	403.86	24.93	45.00	4.53
	386.28	26.74	44.58	4.60
	405.20	26.18	46.15	4.89
0.5 nm	400.42	26.29	53.06	5.58
	405.34	24.83	54.50	5.48
	430.97	27.17	49.66	5.81

Table S1. Summary of photovoltaic parameters of devices with 0.5 nm and 1.2 nm LiF interlayer fabricated in the same batch.

Table S2. Summary of photovoltaic parameters of devices during one week storing.

Gr-Si	Storing	$V_{\rm OC}({\rm mV})$	$J_{\rm SC}$ (mA/cm ²)	FF (%)	PCE (%)
Solar cells	time				
	(day)				
Pristine-1	0	327.75	24.30	45.23	3.60
	1	400.21	25.50	53.45	5.45
	2	389.11	25.08	53.18	5.19
	3	405.34	24.83	54.50	5.48
	7	438.45	24.40	50.18	5.37
Pristine-2	0	347.26	27.70	47.57	4.58
	1	408.61	27.03	54.95	6.07
	2	400.26	27.88	52.55	5.86
	3	424.83	27.11	54.23	6.25
HNO ₃ Doped	7	423.07	28.87	48.98	5.98
	0	490.57	27.86	66.92	9.15
	1	462.44	23.90	39.43	4.36

References:

- 1. A. Tataroğlu and Ş. Altındal, *Microelectron Eng*, 2008, **85**, 233-237.
- 2. D. Pysch, A. Mette and S. W. Glunz, *Sol Energ Mat Sol C*, 2007, **91**, 1698-1706.
- Y. Zhang, W. Cui, Y. Zhu, F. Zu, L. Liao, S.-T. Lee and B. Sun, *Energy Environ. Sci.*, 2014.
- 4. G. K. Reeves and H. B. Harrison, *Electron Device Letters*, 1982, **3**, 111-113.



Figure. S1



Figure S2.